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JUL 2 4 2006 EXPEDITED PROCEDURE
EXAMINING GROUP 2800

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:

Huang, et al.

Docket No.:

TSM03-0340

Serial No.:

10/706,156

Art Unit:

2811

Filed:

November 12, 2003

Examiner:

Owens, Douglas W.

For:

Integration Film Scheme for Copper/Low-k Interconnect

Mail Stop AF Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

RESPONSE UNDER 37 CFR § 1.116

Dear Sir:

Applicants respectfully submit the following remarks in response to Examiner's Office Action dated June 2, 2006, which Action is made final. Applicants respectfully request that these remarks be entered in pursuant to the provisions of 37 CFR § 1.116, and respectfully request reconsideration of claims 1-7, and 52-55.

Do not enter amendment. 3/14/07 Of O